

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified)		7954/DSM/BCVD/JW	10/697,731
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Yim, et al.	Confirmation No.:
(Use several sheets if necessary)		Filing Date	Group
Examiner <i>M. Marc</i>		October 29, 2003	3661

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
<i>m.m</i>	A1	2002/0078770	06/27/2002	Hunter	73	865.9	
	A2	2002/0092369	07/18/2002	Hunter	73	865.9	
	A3	2002/0101508	08/01/2002	Pollack	348	85	
	A4	2003/0001083	01/02/2003	Corrado et al.	250	239	
	A5	2003/0198376	10/23/2003	Sadighi et al.	382	153	
	A6	2003/0202092	10/30/2003	Sadighi et al.	348	87	
	A7	4,819,167	04/04/1989	Cheng, et al.	364	167.01	
	A8	5,452,521	09/26/1995	Niewmierzycki	33	520	
	A9	5,483,138	01/09/1996	Shmookler, et al.	318	568.16	
	A10	5,844,683	12/01/1998	Pavloski, et al.	356	399	
	A11	5,917,601	06/29/1999	Shimazaki, et al.	356	375	
	A12	5,980,194	11/09/1999	Freerks, et al.	414	754	
	A13	6,002,840	12/14/1999	Hofmeister	395	80	
	A14	6,051,113	04/18/2000	Moslehi	204	192.12	
	A15	6,198,976 B1	03/06/2001	Sundar, et al.	700	59	
	A16	6,244,121 B1	06/12/2001	Hunter	73	865.9	
	A17	6,313,596 B1	11/06/2001	Wyka, et al.	318	640	
	A18	6,468,816 B2	10/22/2002	Hunter	438	14	
	A19	6,648,730	11/18/2003	Chokshi et al.	451	6	

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>

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OTHER ART		
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
<i>m.m.</i>	C1	"Wafercam [™] System: Wireless Camera System for Semiconductor Processing Robotic Arm Calibration", www.gtweed.com/semiconductor/Wafercam.htm , printed 12/10/2002
	C2	
	C3	
Examiner	<i>McDiemel m. m.</i>	Date Considered <i>10-06-05</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.		